



PATENT APPLICATION  
Docket No. 9898-320  
Client No. SS-16412-US DIV

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Yun-Hyeok Im and Young-Hoon Ro**  
Serial No.: **10/646,444** Art Unit: **2811**  
Filed: **August 21, 2003** Examiner: **not yet assigned**  
For: **SEMICONDUCTOR PACKAGE HAVING DAM AND METHOD  
FOR FABRICATING THE SAME**  
Confirmation No. **9520**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

under 37 CFR 1.97 (b); or

(Within three months of filing national application; or date of entry of International application;  
or before mailing date of first office action on the merits; whichever occurs last)

Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

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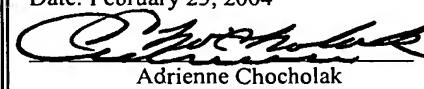
Respectfully submitted,

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\_\_\_\_\_  
Adrienne Chocholak



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**INFORMATION DISCLOSURE CITATION  
FORM PTO-1449 (Modified)**

**FOREIGN PATENT DOCUMENTS**

<u>Exam</u>	<u>Document</u>	<u>Publication</u>		<u>Name</u>
<u>Init</u>	<u>Number</u>	<u>Date</u>	<u>Country</u>	
_____	1994-023007	12/1/1998	Korea	
_____	1997-039212	8/18/1997	Korea	

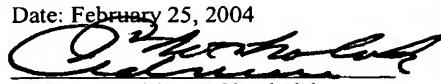
**OTHER DOCUMENTS**

<u>Exam</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	English language of Korean Patent Publication No. 1994-023007.
_____	_____	English language of Korean Patent Publication No. 1997-039212.

Examiner: \_\_\_\_\_

Date Considered: \_\_\_\_\_

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